



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ATTY.'S DOCKET: 00 P 9031 US

In re the application of: )  
Helmut Tews et al. ) Group Art: 2813  
Serial No.: 09/714,356 ) Examiner: Chen, Jack SJ.  
Filing Date: November 16, 2000 )  
Title: NITROGEN IMPLANTATION USING )  
A SHADOW EFFECT TO CONTROL )  
GATE OXIDE THICKNESS IN )  
DRAM SEMICONDUCTORS )

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TECHNOLOGY CENTER 2813  
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AMENDMENT UNDER 37 CFR §1.115

Honorable Commissioner of Patents and Trademarks  
Washington, D.C. 20231

Sir:

In reply to the Office Action mailed October 4, 2002,  
which rejected the claims in the above-identified patent  
application, applicants respectfully request reconsideration  
based on the amendments hereinafter set forth.

IN THE ABSTRACT:

A new abstract page is submitted herewith on a separate  
sheet. As revised, the new abstract is: within the range of 50  
to 150 words; is devoid of legal phraseology and now satisfies  
the abstract requirements set forth in MPEP.

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